

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:

Jaiswal	Docket No.: TI-34403.1
Serial No.: TBD	Examiner: TBD
Filed: 10/6/2003	Art Unit: TBD
For: CONTROL OF NICHROME RESISTOR TEMPERATURE COEFFICIENT USING RF PLASMA SPUTTER ETCH	

**PRELIMINARY AMENDMENT**

Honorable Assistant Commissioner  
of Patents  
Washington, D.C. 20231

"EXPRESS MAILING" Mailing Label No. EL547743027US

Date of Deposit: October 6, 2003.

Prior to the examination of the above identified application, please amend the above referenced Application as follows: